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REPLY UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP

### AMENDMENT TRANSMITTAL LETTER

Docket No.  
1248-0673P

Application No.  
10/668,186-Conf. #4125

Filing Date  
September 24, 2003

Examiner  
L. M. Schillinger

Art Unit  
2813

Applicant(s): Yutaka TAKAFUJI et al.

Invention: SINGLE-CRYSTAL SILICON SUBSTRATE, SOI SUBSTRATE, SEMICONDUCTOR  
DEVICE, DISPLAY DEVICE, AND MANUFACTURING METHOD OF SEMICONDUCTOR  
DEVICE

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	57	- 57 =		x	
Independent Claims	14	- 14 =		x	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b>					0.00

☒ Large Entity

☐ Small Entity

☒ No additional fee is required for this amendment.

☐ Please charge Deposit Account No. \_\_\_\_\_ in the amount of \$ \_\_\_\_\_.  
A duplicate copy of this sheet is enclosed.

☐ A check in the amount of \$ \_\_\_\_\_ to cover the filing fee is enclosed.

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☒ The Director is hereby authorized to charge and credit Deposit Account No. 02-2448  
as described below. A duplicate copy of this sheet is enclosed.

☒ Credit any overpayment.

☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.

*Charles Gorenstein*  
Charles Gorenstein  
Attorney Reg. No.: 29,271

Dated: September 14, 2005

BIRCH, STEWART, KOLASCH & BIRCH, LLP  
8110 Gatehouse Rd., Suite 100 East  
P.O. Box 747  
Falls Church, Virginia 22040-0747  
(703) 205-8000



Docket No.: 1248-0673P  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Yutaka TAKAFUJI et al.

Application No.: 10/668,186

Confirmation No.: 4125

Filed: September 24, 2003

Art Unit: 2813

For: SINGLE-CRYSTAL SILICON SUBSTRATE,  
SOI SUBSTRATE, SEMICONDUCTOR  
DEVICE, DISPLAY DEVICE, AND  
MANUFACTURING METHOD OF  
SEMICONDUCTOR DEVICE

Examiner: L. M. Schillinger

**REPLY AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)**

**MS AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated June 27, 2005, please amend the above-identified

U.S. patent application as follows:

**Remarks/Arguments** begin on page 2 of this paper.